

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 293375US26PCT		SERIAL NO. 10/585,732	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Toshio HASEGAWA			
				FILING DATE July 12, 2006		GROUP 2823	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES      NO		
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AW	Hirotaka HAMAMURA, et al., "TiN Films Prepared by Flow Modulation Chemical Vapor Deposition Using TiCl <sub>4</sub> and NH <sub>3</sub> ", Japanese Journal of Applied Physics, Vol. 40, No. 3A, Part 1, XP001078015, March 1, 2003, pages 1517-1521					
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner				/Khiem Nguyen/		Date Considered      11/20/2009	
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /KN/